

3-21-02
JP
Docket: 740819-725

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of)
Yasutoshi OKUNO et al.)
Japanese Priority Application No. 2001-030068) Attn: Application
Japanese Priority Date: February 6, 2001) Branch
For: METHOD FOR FABRICATING)
SEMICONDUCTOR DEVICE) Date: January 2, 2002



INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner for Patents and Trademarks
Washington, D.C. 20231

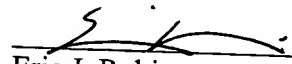
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the references listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on PTO Form-1449 are discussed in the specification of the present application.

Copies of these references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,


Eric J. Robinson
Registration No. 38,285

NIXON PEABODY LLP
8180 Greensboro Drive, Suite 800
McLean, Virginia 22102
(703) 790-9110